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## OGI Develops New Cut Proportion Analyzer

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(Rapaport...May 31, 2006) OGI Systems created a new, high resolution, non-contact optical scanner for polished stones, designed exclusively for GIA Instruments, the company reports.

"OGI has invested substantial resources to develop a new, high resolution Cut Proportion Analyzer " said president Daniel Ben Zano. He added that OGI designed both software and hardware technology specific to the needs of GIA instruments.

Incorporating new electronic standards in OGI Systems' Plug n' Play scanner for GIA FacetScan, jewelers now use a computer's USB port for connecting hardware.

OGI Systems was established in 1990 and offers products including diamond cut grading systems, rough diamond optimization systems, laser sawing and cutting, laser-marking and laser inscription machines.

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